



8-30-02

2813

#15/Changes  
9/18/02  
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ATTORNEY DOCKET NO. NECK 17.552

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Hiroshi TANABE

Serial No.: 09/614,286

Filed: July 12, 2000

Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS  
AT DESIRED POSITIONS ON A SUBSTRATE**

Examiner: Timothy J. Sutton

Group Art Unit: 2813

Assistant Commission for Patents  
Washington, D.C. 20231

CHANGE IN CORRESPONDENCE ADDRESS

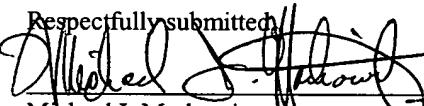
SIR:

It is respectfully requested that any future correspondence regarding the above-referenced application be directed to Applicant's attorneys (previously appointed) at the following new correspondence address:

Katten Muchin Zavis Rosenman  
575 Madison Avenue  
New York, New York 10022  
Phone: (212) 940-8800  
Fax: (212) 940-8986 or (212) 940-8987

Any inquiries regarding this change in address may be directed to the Applicant's undersigned attorney at the above-referenced telephone numbers.

Our CUSTOMER NUMBER 026304 remains the same.

Respectfully submitted,  
  
Michael I. Markowitz  
Reg. No. 30,659

EV096421016US  
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